

PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

A N	APPL NUM 10036787	FILING DATE 10/19/2001	CLASS 216	SUBCLASS 1746	GAU	EXAMINER <i>R Culbert</i>
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** FOREIGN APPLICATIONS VERIFIED: *RC*

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PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>	
Foreign priority claimed 35 USC 119 conditions met Verified and Acknowledged Examiner's initials <i>R Culbert</i>		<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	ATTORNEY DOCKET NO 199372003600
TITLE : Method and apparatus of processing surface of substrate			
U.S. DEPT. OF COMM./PAT. & TM-PTO-436L (Rev. 12-94)			

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED	
			Total Claims	Print Claim for O.G.
ISSUE FEE		Primary Examiner	DRAWING	
Amount Due	Date Paid		Sheets Drwg.	Figs. Drwg.
TERMINAL DISCLAIMER		Application Examiner		
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